

Transaction Information

Tool ID	TCP2103
Tool Status	Connected
Location	Malta, USA
Wafer Size	300 mm
Fab Section	Test
Tool Available Date	2024-01-03

General Product Information

Vendor Supplier	TEL
Model	Precio
Vintage	2012
Serial No	PP01822
Asset Description	Prober wafer handler for test systems
Software Version	4.9.4_1601-W
CIM	GEM
Process	Test

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	Prober	1	OK
Handler System	Loader	1	OK
Factory Interface	FOUP	1	OK
Options System	Chiller	1	OK
Others			
Main System	Loader Attached	1	OK

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
NONE	0	OK

Missing/Faulty Parts / Accesories List

Description	Quantity
NONE	0

Tool Pictures

General

Prober with attached loader and chiller



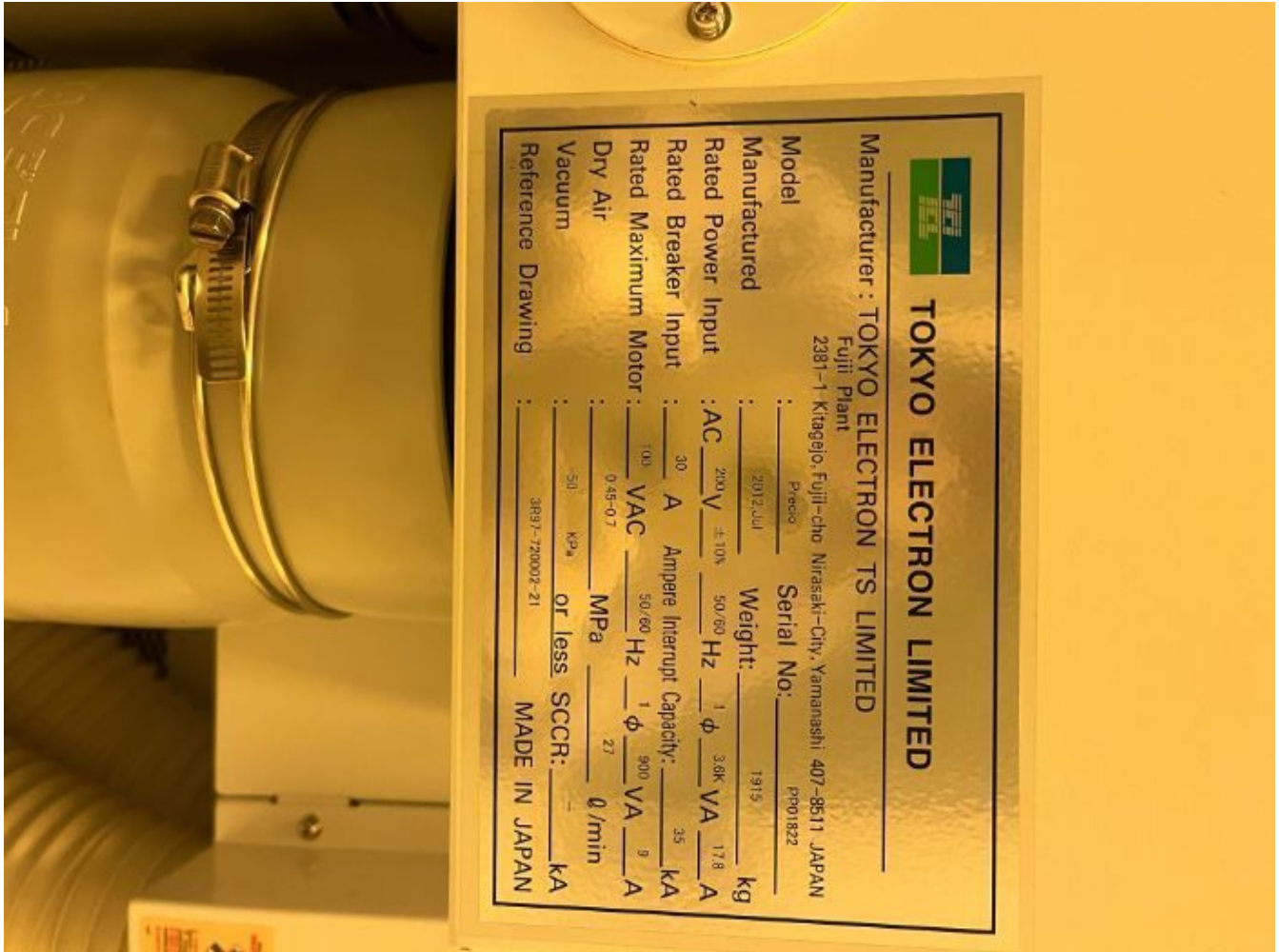
General

Prober with attached loader and chiller



Manufacture Serial

prober S/N



TOKYO ELECTRON LIMITED

Manufacturer : TOKYO ELECTRON TS LIMITED

Fuji Plant
2381-T Kitagojo-Fujii-cho Nirasaki-City, Yamanaishi 407-8511 JAPAN

Model : _____ Date : _____ Serial No. : _____ PFD01822

Manufactured : _____ 2012 Jul Weight : _____ 1915 kg

Rated Power Input : AC 200V $\pm 10\%$ 50/60 Hz 1 ϕ 3.6k VA 17.8 A

Rated Breaker Input : 30 A Ampere Interrupt Capacity : _____ 35 kA

Rated Maximum Motor : 100 VAC 50/60 Hz 1 ϕ 900 VA 9 A

Dry Air : 0.48-0.7 MPa _____ 27 Q/min

Vacuum : 5.0 KPa_a or less SCCR : _____ kA

Reference Drawing : 3R91-720002-21 MADE IN JAPAN

Additional Tool Data Files